



PATENT
1691-0177PUS2

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Hiroyuki FUKUYAMA

Appl. No.: 10/809,398 Group: 1722

Filed: March 26, 2004 Examiner: Song

For: SINGLE CRYSTALLINE ALUMINUM
NITRIDE FILM, METHOD OF FORMING THE
SAME, BASE SUBSTRATE FOR GROUP III
ELEMENT NITRIDE FILM, LIGHT EMITTING
DEVICE AND SURFACE ACOUSTIC WAVE DEVICE

REQUEST FOR RECONSIDERATION

Commissioner of Patents
P.O. Box 1450
Alexandria, Virginia 22313

Sir:

The following Remarks are respectfully submitted in connection with the above-identified application in response to the Official Action of May 3, 2005, the period for response to which having been extended up to and including September 3, 2005.

No specification or claim amendments are made.